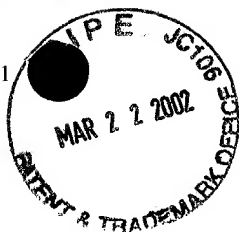


::ODMA\MHODMA\iManage;297122;1
LMT/pdd
March 13, 2002



PATENT APPLICATION
Attorney's Docket No.: 2719.2016-001 (18547-042110)

Rec'd
6/A
JP
9/4/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Glenn McGall, Lisa Kajisa and Bradley A. Kreger
Application No.: 09/871,610 Group: Not assigned
Filed: June 1, 2001 Examiner: Not assigned
For: New Methods for Array Preparation Using Substrate Rotation

CERTIFICATE OF MAILING	
I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to Assistant Commissioner for Patents, P.O. Box 2327, Arlington, VA 22202	
on <u>3/18/02</u>	<u>Paula Depelteau</u>
Date	Signature
<u>PAULA DEPELTEAU</u>	
Typed or printed name of person signing certificate	

PRELIMINARY AMENDMENT

Assistant Commissioner for Patents
P.O. Box 2327
Arlington, VA 22202

Sir:

Please amend the application as follows:

In the Specification

Please replace the paragraph at page 3, line 28 with the following paragraph:

Figure 1 shows the rotation positions for a wafer during array preparation. The position notations are used in the rotation prompts on the computer screen. By using these notations the

03/26/2002 HROCHA1 00000019 09871610

01 FC:118

1440.00 UP